

# PRESSURE AND ACOUSTICS

#### THE MODAL SHOP

#### **APRIL 2019**





#### PATRICK TIMMONS

## **TODAY'S AGENDA**

Pressure Sensors vs.
 Condenser Microphones

Pressure Sensor Design

- Acoustic Microphone Design
- Calibration Techniques For Both







## PRESSURE SENSOR VS. MICROPHONES

#### **Pressure Sensors**

- Piezoelectric
- Full Scale: Varies by design.
  - 7kPa [1 psi]
  - 700 MPa [100 ksi]
- Rugged
- Operation to 650° C
- Wide Variety of Form Factors



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SENSORS



#### **Condenser Microphones**

- Variable Capacitance
- Full Scale: Varies by design
  - 600 Pa [150 dB SPL]
  - 20 kPa [180 dB SPL]
- Relatively Fragile
- Operation to 120° C
- Standardized
  Sizes

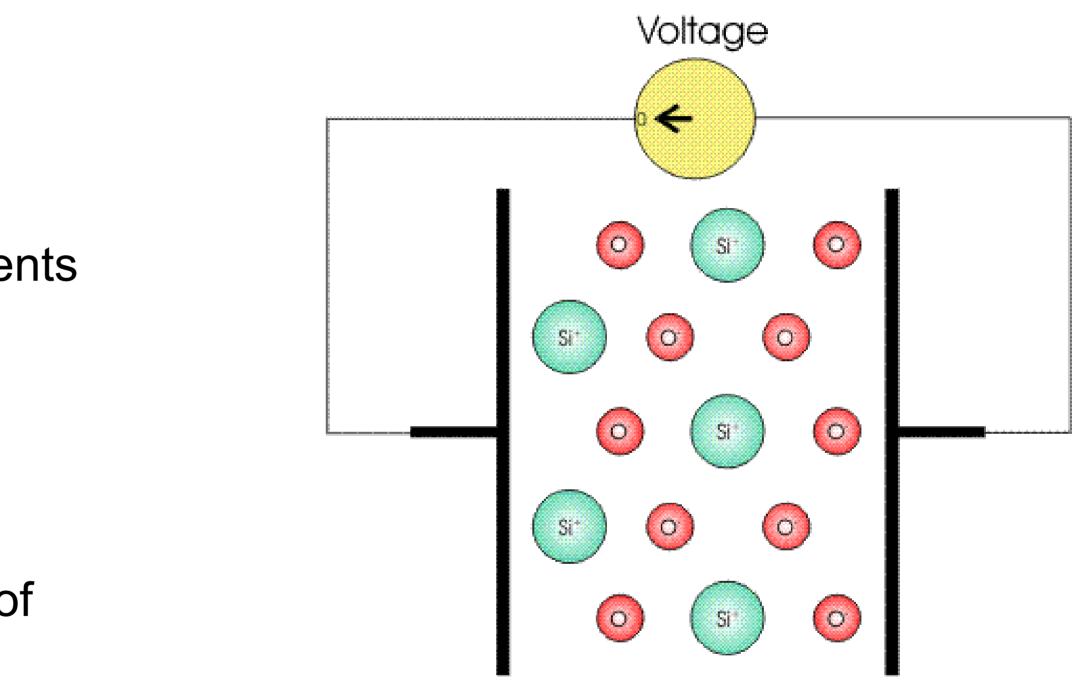


## **PRESSURE SENSOR – SENSING ELEMENT**

- Sensing element is usually quartz
  - Naturally occurring •
  - Stable
  - Insensitive to temperature transients •
- Alternative is ceramic
  - Pyroelectric output •
  - Aging causes logarithmic decay of • output





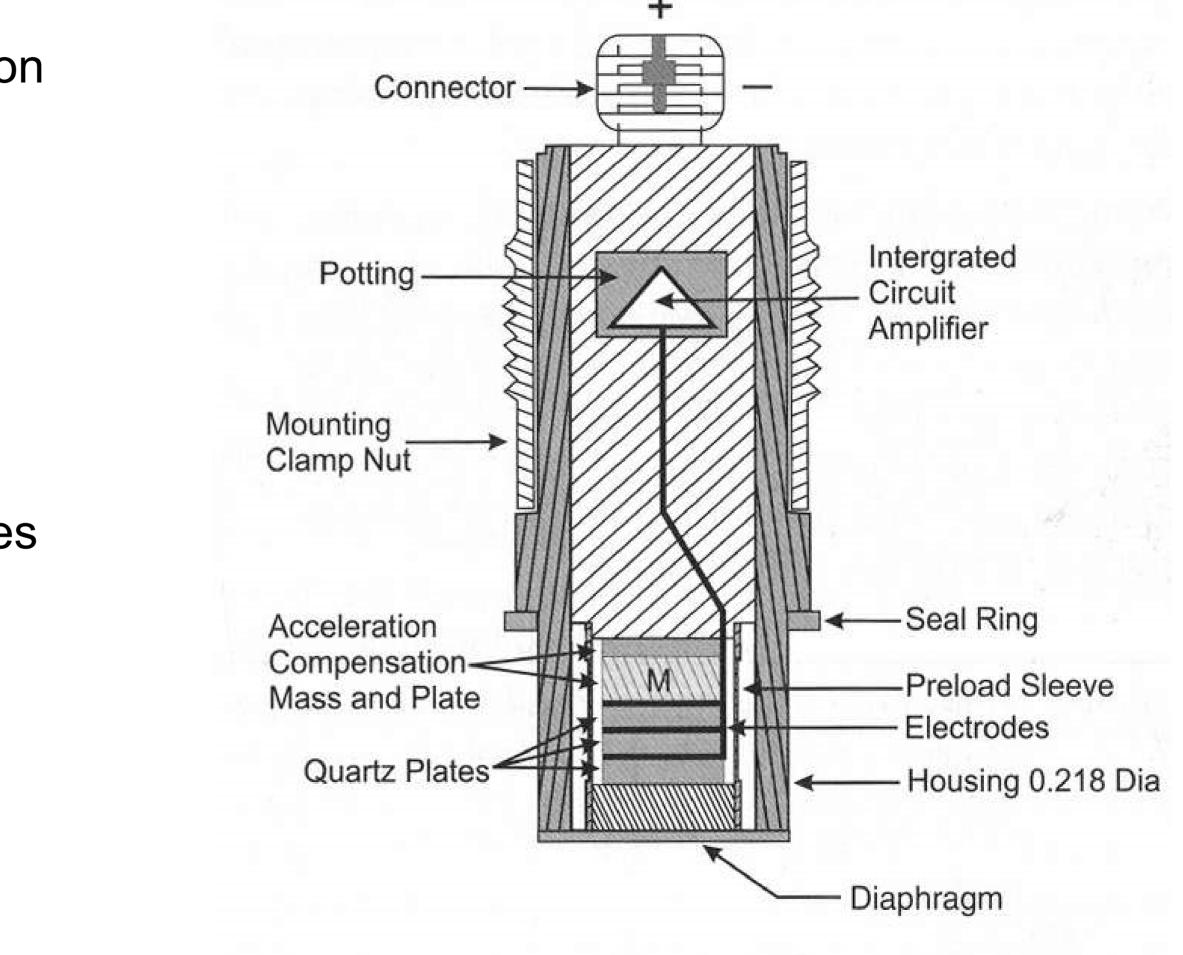


## **PRESSURE SENSOR – SENSING ELEMENT**

- Quartz is arranged in compression geometry
- High impedance output from crystal is amplified
  - Internally to the sensor
  - Externally for high temperatures
- Fairly massive diaphragm
- 2 wire output







## **PRESSURE SENSOR – SENSING ELEMENT**

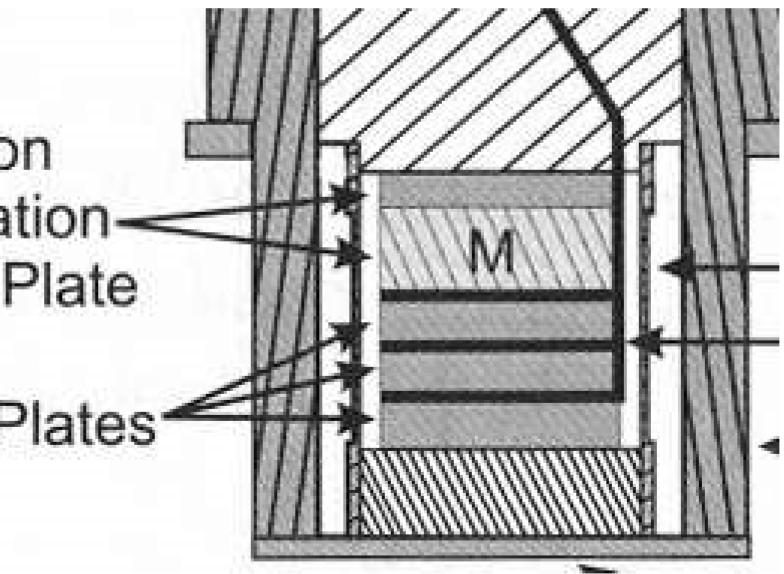
- Acceleration Compensation
- Creates a small accelerometer
  - Signal is subtracted from the pressure signal

Acceleration Compensation-Mass and Plate

**Quartz Plates** 







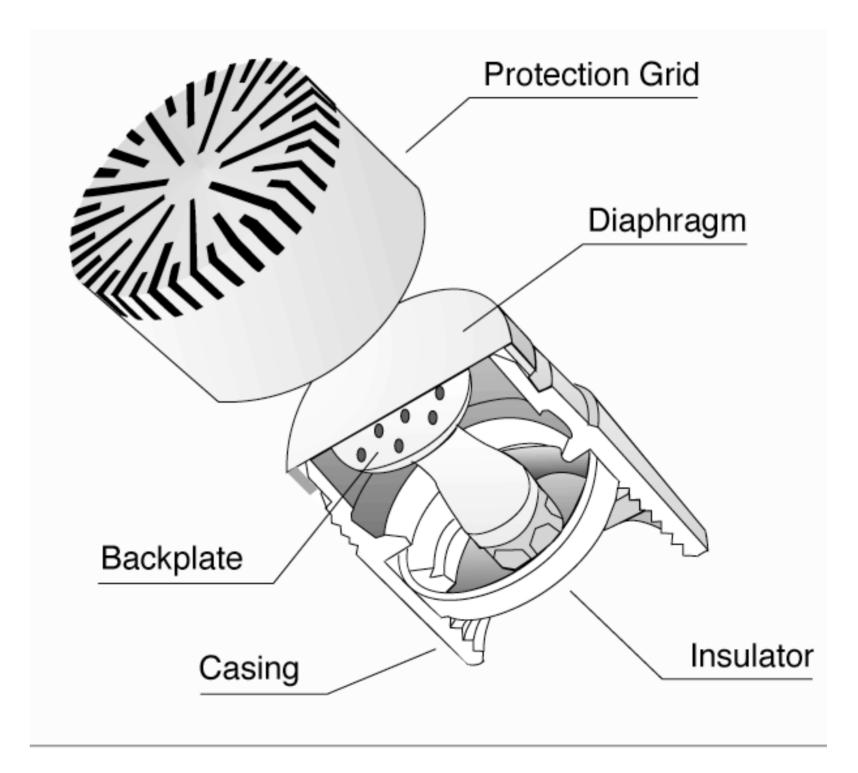
## **ACOUSTIC MICROPHONE – SENSING ELEMENT**

- Varying capacitance creates a varying output voltage
  - Diaphragm
  - Backplate
- Very thin diaphragm
  - High sensitivity
  - Fragility
- Standard diaphragm
  diameters : <sup>1</sup>/<sub>4</sub>", <sup>1</sup>/<sub>2</sub>", 1"





 Low frequency response determined by acoustic venting



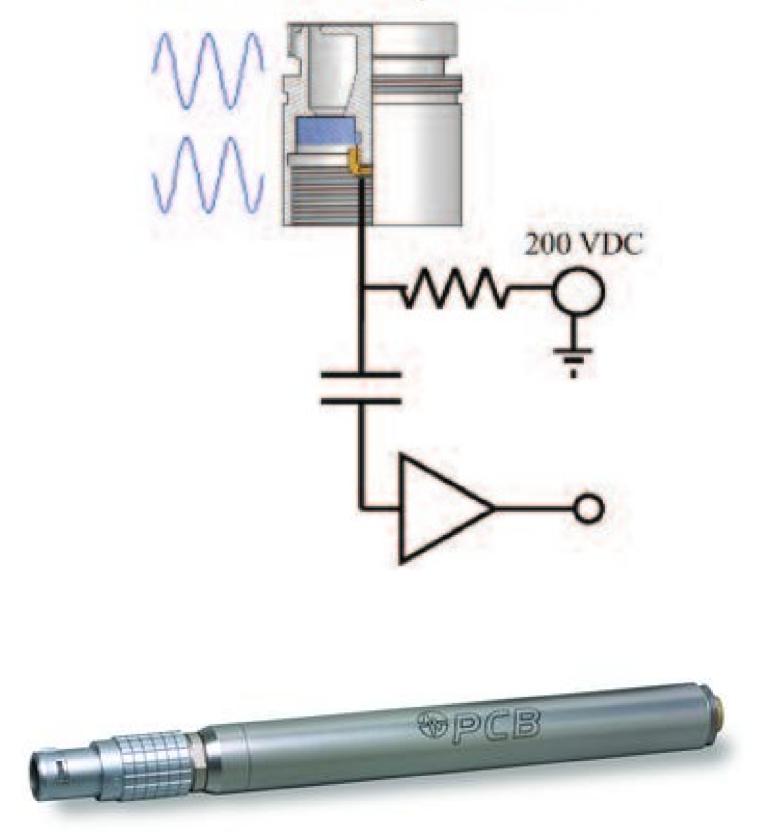
## **ACOUSTIC MICROPHONE – SIGNAL CONDITIONING**

- Capacitor must be polarized
- Externally polarized
  - 200 V DC
  - External source
- Preamplifier required
  - Multiple pin LEMO





#### **Traditional Externally Polarized**

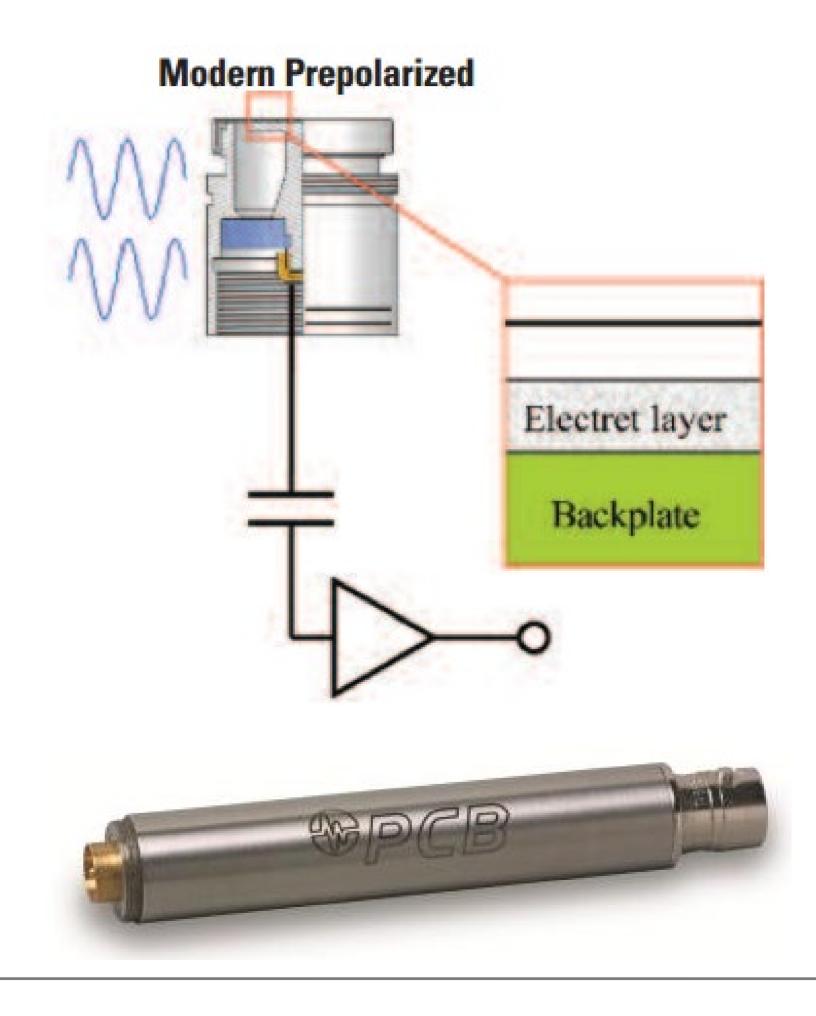


## **ACOUSTIC MICROPHONE – SIGNAL CONDITIONING**

- Capacitor must be polarized
- Prepolarized Backplate
  - Enables simple 2-wire cabling
  - Embedded electronics for ICP® operation
- Interchangeable with ICP® accelerometers and pressure sensors on a single DAQ channel
- Preamplifier required
  - Usually ICP coaxial connector





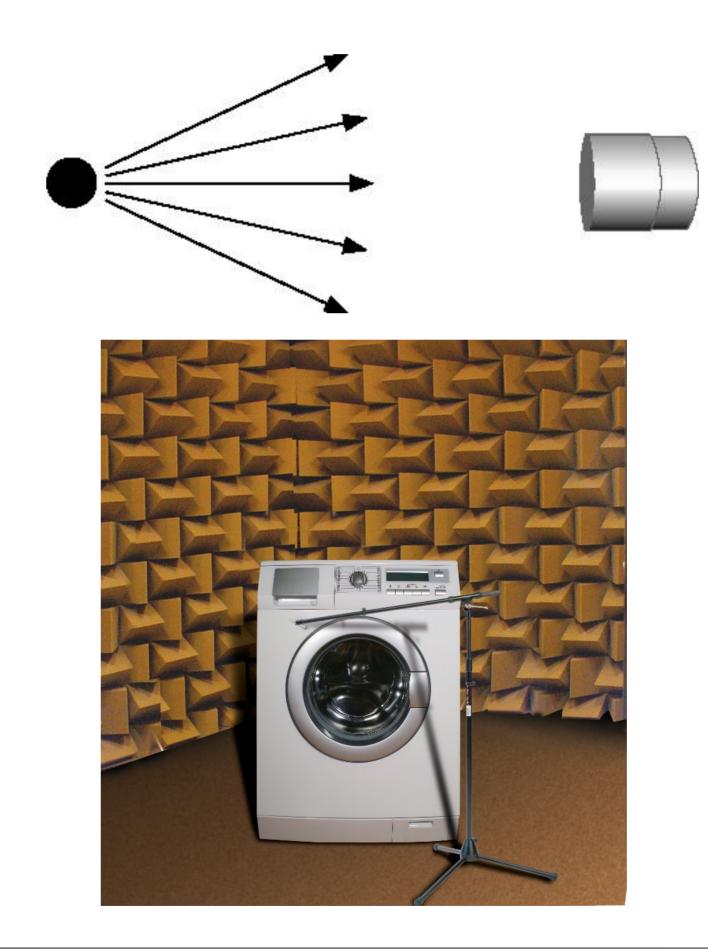


## **CONDENSER MICROPHONES – FREE FIELD RESPONSE**

- Free Field Response
- Designed for single pressure sources
- Modeled as 0 degree incidence
- Low reflection environment
- Frequency dependent corrections applied





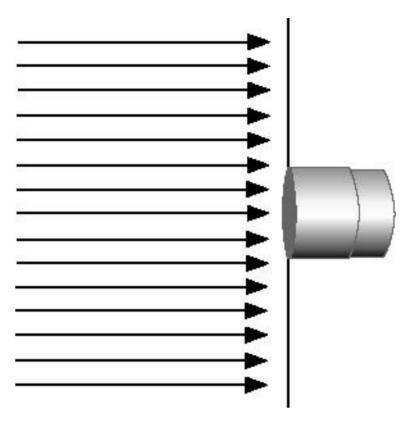


## **CONDENSER MICROPHONES – PRESSURE FIELD RESPONSE**

- Measures pressure at diaphragm
- aka wall mounted
- Microphone is 'built in' to the existing boundary condition
- Models pressure as equal throughout the field







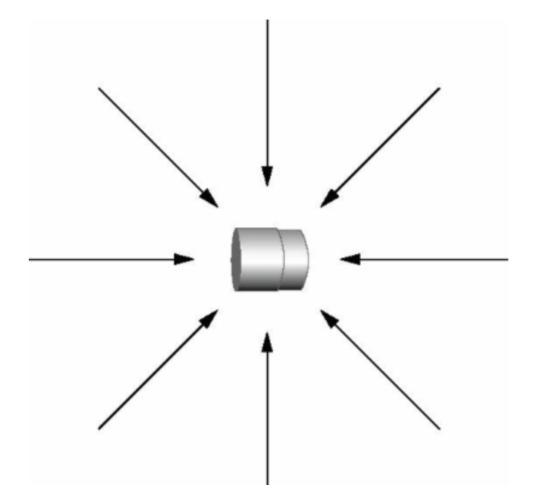


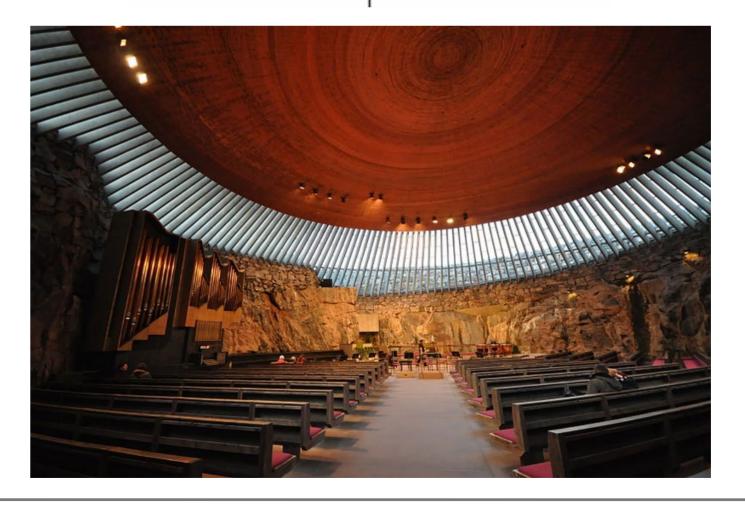
## **CONDENSER MICROPHONES – RANDOM INCIDENCE RESPONSE**

- Random incidence, aka diffuse field
- Modeled as omni-directional sources
- Used in highly reflective environments
- Frequency dependent corrections specific to manufacturer









## PRESSURE SENSOR SOUND FIELD INTERACTION

- Primarily pressure field measurements
- Special designs for applications like free-field blast









## CALIBRATION

- Microphone calibration
  - Reciprocity
  - Insert voltage
  - Electrostatic actuator





- Pressure sensor calibration
  - Step method
  - Impulse method
  - Media
    - Pneumatic
    - Inert gas
    - Oil

## **CALIBRATION – CONDENSER MICROPHONES**

#### IEC 61094 defines

- Condenser microphones
- Calibration methods
- Calibration methods
  - Reciprocity
    - For primary
  - Pistonphone or speakerphone
    - For field check





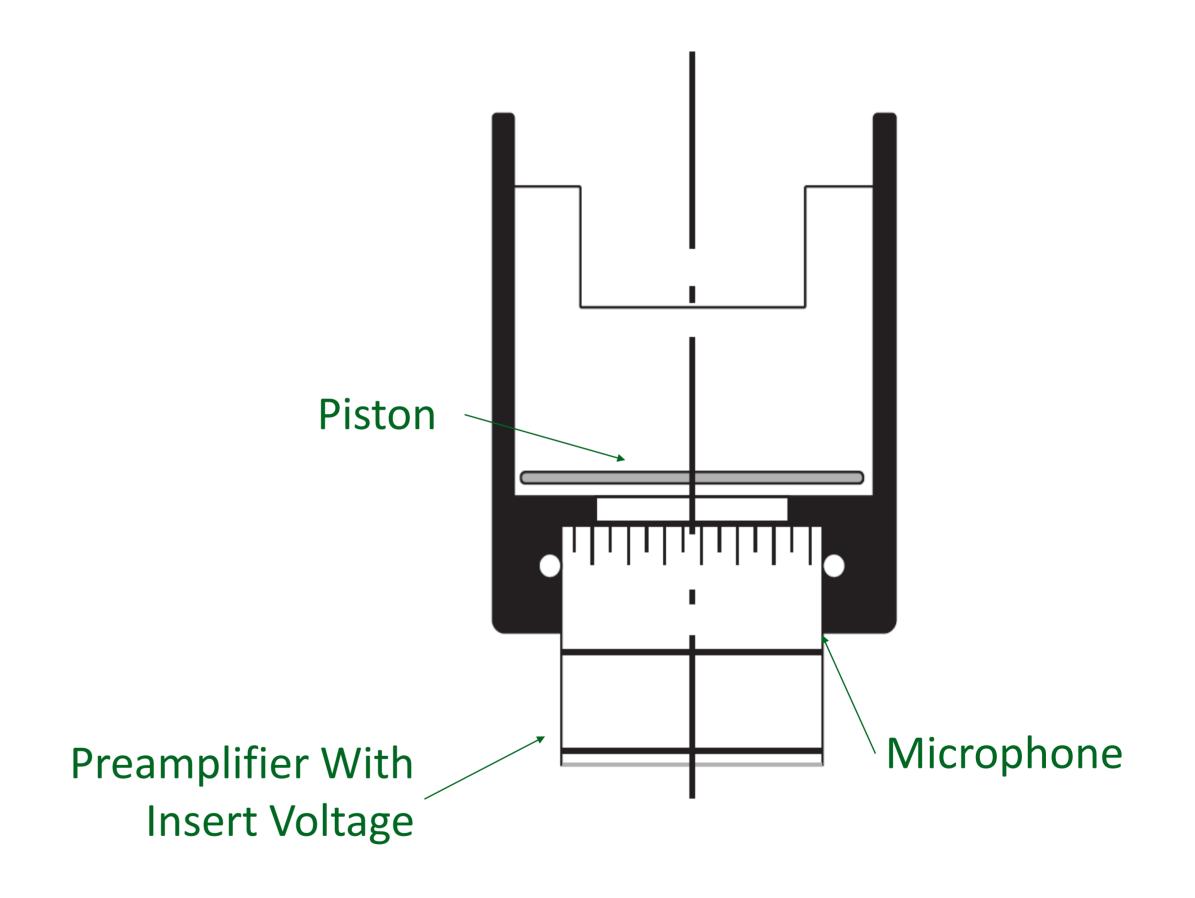
- Insert voltage
  - Laboratory calibration
- Electrostatic actuator
  - Frequency response in laboratory
- Comparison Method

- Components
  - Sound Source
    - Sound Calibrator
    - Pistonphone (shown)
  - MUT Microphone Under Test
  - Preamplifier With Insert Voltage Option



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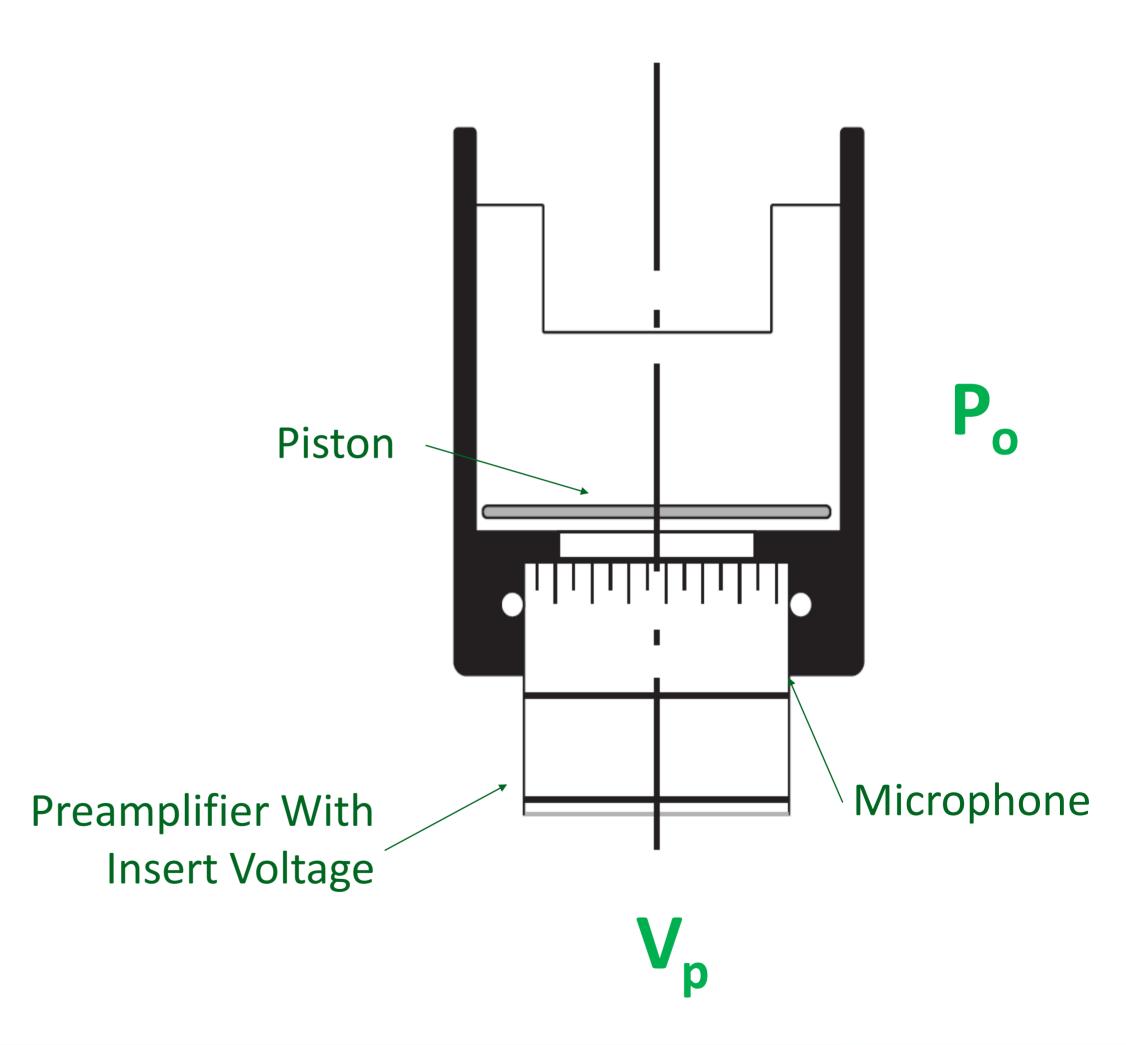
SENSORS



- Step 1
  - Piston creates oscillating pressure P<sub>0</sub>.
  - Measure Preamp Output Voltage V<sub>p</sub>.





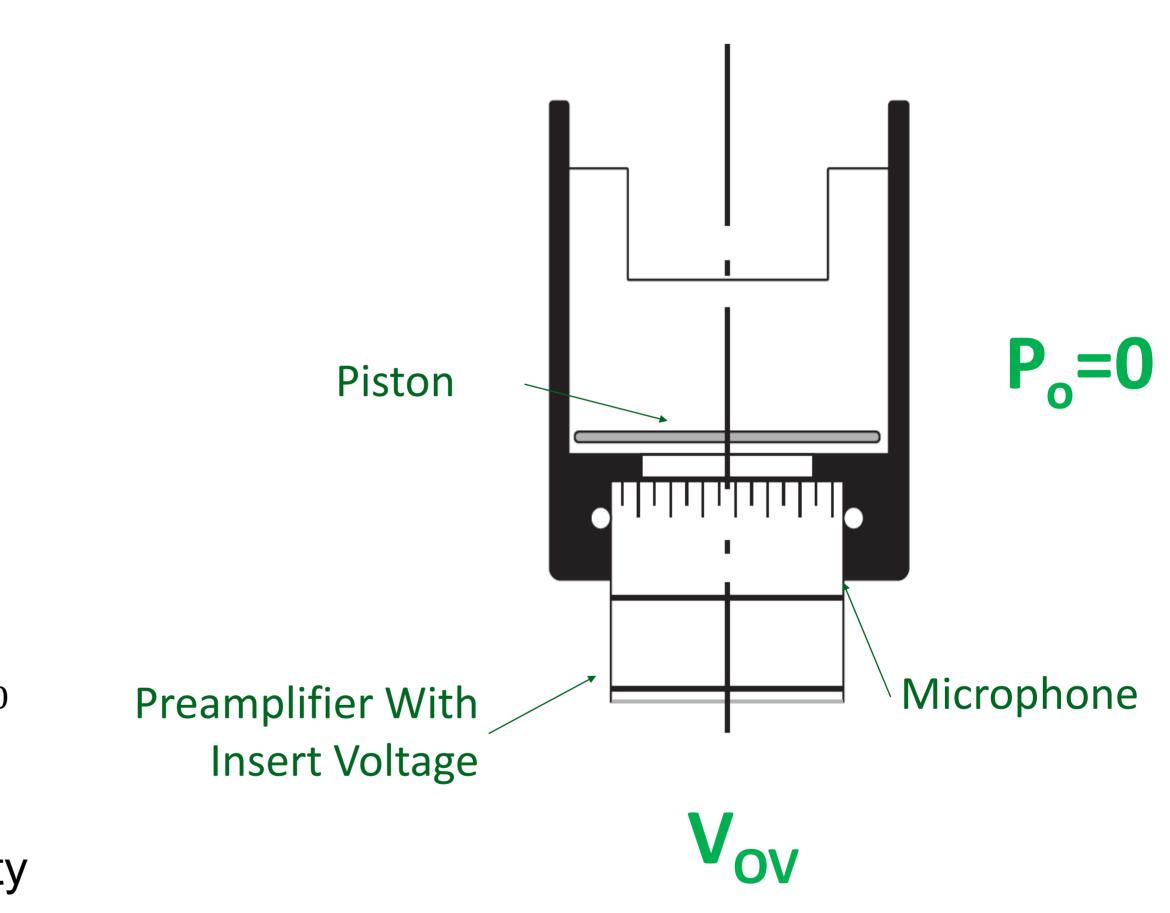


- Step 2
  - Turn off sound source
  - Apply insert voltage  $V_{IV}$  in series with microphone and measure  $V_{IV}$
  - Measure preamp output V<sub>OV</sub>
  - Adjust V<sub>IV</sub>' so that V<sub>OV</sub> = V<sub>P</sub>. This implies that V<sub>IV</sub>.at this condition = Mic output voltage at the original P<sub>0</sub> from Step 1
  - OCS =  $\frac{V_{IV}}{P_0}$  = Open Circuit Sensitivity



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**SENSORS** 



- OCS is a property of the microphone
  - Isolated from the preamplifier
- OCS is typically measured at a fixed frequency of the sound source
  - (the reference frequency)
- OCS can be expressed in dB or base units

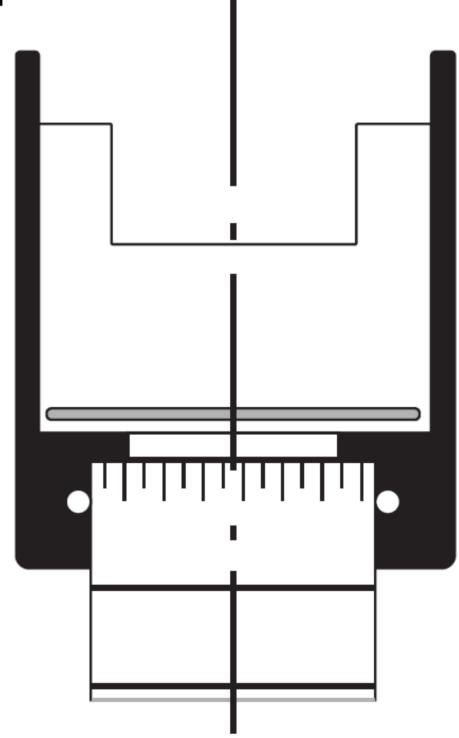
• 
$$20 \times log_{10} \left[ \frac{\frac{V_{IV}}{P_0} \left(\frac{milliVolts}{Pascal}\right)}{\frac{1000 milliVolts}{Pascal}} \right]$$



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 Broadband frequency response is measured using an electrostatic actuator



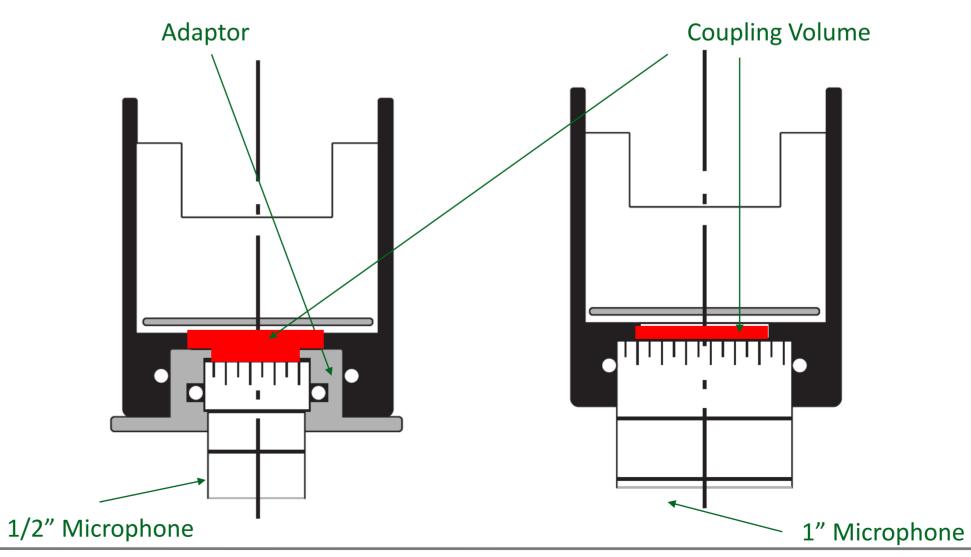
## **NOTES ABOUT PISTONPHONES**

- Consistent coupling volume is • required
  - Adaptor design
- Volume Correction factor
  - Must be applied
  - Varies with microphone size
  - Varies with/without protection grid
- Sensitivity to atmospheric • pressure
  - Supplied with a calibrated barometer
  - Barometer provide correction in dB





- Sensitivity to alignment • Changes volume
  - Sound Calibrators •
    - Different than pistophone •
    - Loudspeaker with current feedback
    - None of the issues above



## **ELECTROSTATIC ACTUATOR METHOD**

- Electrostatic actuators are described in IEC 61094-6
- The actuator is a rigid, electrically conductive plate
  - Placed close to and parallel to the microphone diaphragm
  - Holes in actuator reduce radiation impedance
- High impedance AC electrical voltages are applied to this capacitor to create a force on the diaphragm
- AC electrical voltages are relatively easily controlled over a wide frequency range





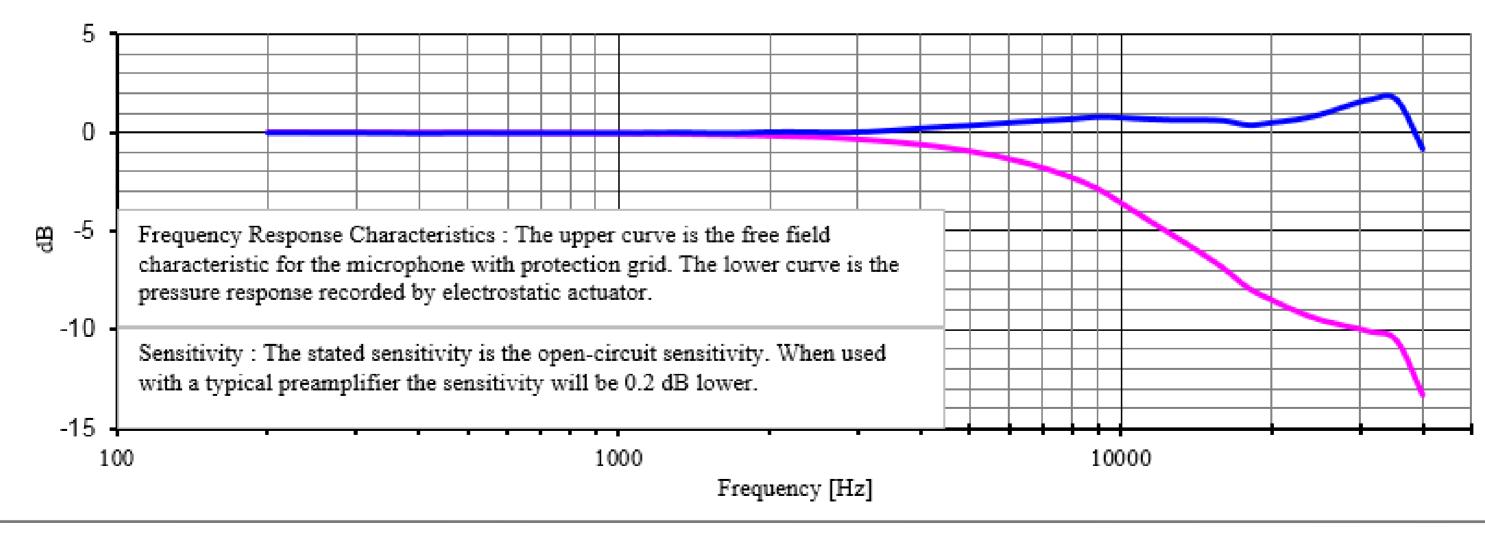






## **ELECTROSTATIC ACTUATOR METHOD**

- The AC voltage is applied using stepped sine excitation
- The microphone output is measured at each frequency
- The result is an electrostatic actuator frequency response spectrum
  - Free field, random incidence, and pressure microphones are 'corrected' based on model with numbers determined through manufacturer testing



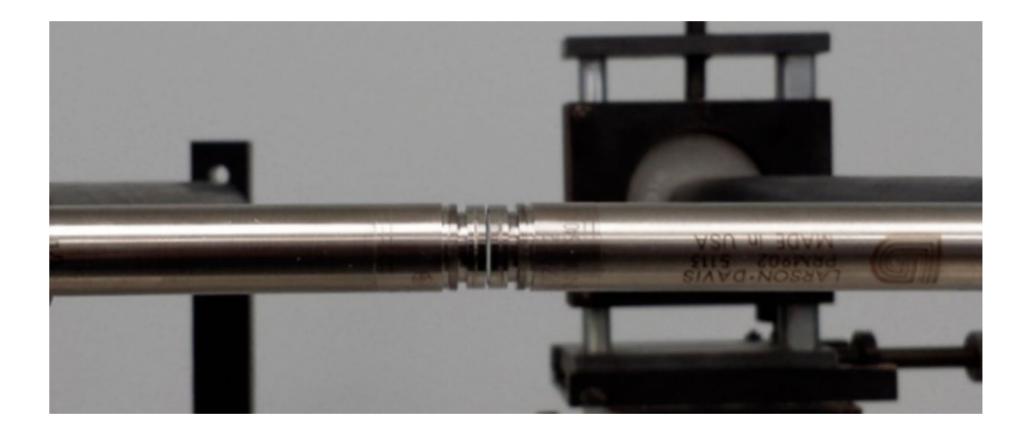




- Acoustic field is applied using stepped sine excitation
- Test microphone is mounted face to face with a reference microphone
- Each microphone output is measured at each frequency
- The result is a pressure response







- $M_{Test}$  sensitivity of the test microphone, in  ${}^{mV}/{}_{Pa}$
- $M_{Ref}$  sensitivity of the reference microphone, in  ${}^{mV}/{}_{Pa}$
- *R<sub>V</sub>* ratio of the voltage output of the test microphone to the voltage output of the reference microphone
- *R<sub>P</sub>* ratio of the sound pressure on the test microphone to the sound pressure on the reference microphone





- *C<sub>F/P</sub>* field correction value
  referenced to the pressure response
  for the test microphone.
- *C<sub>F/P</sub>* field correction value
  referenced to the pressure response
  for the test microphone.



 $M_{Test} = M_{Ref} \times \frac{R_V}{R_P} \times C_{F/P}$ 

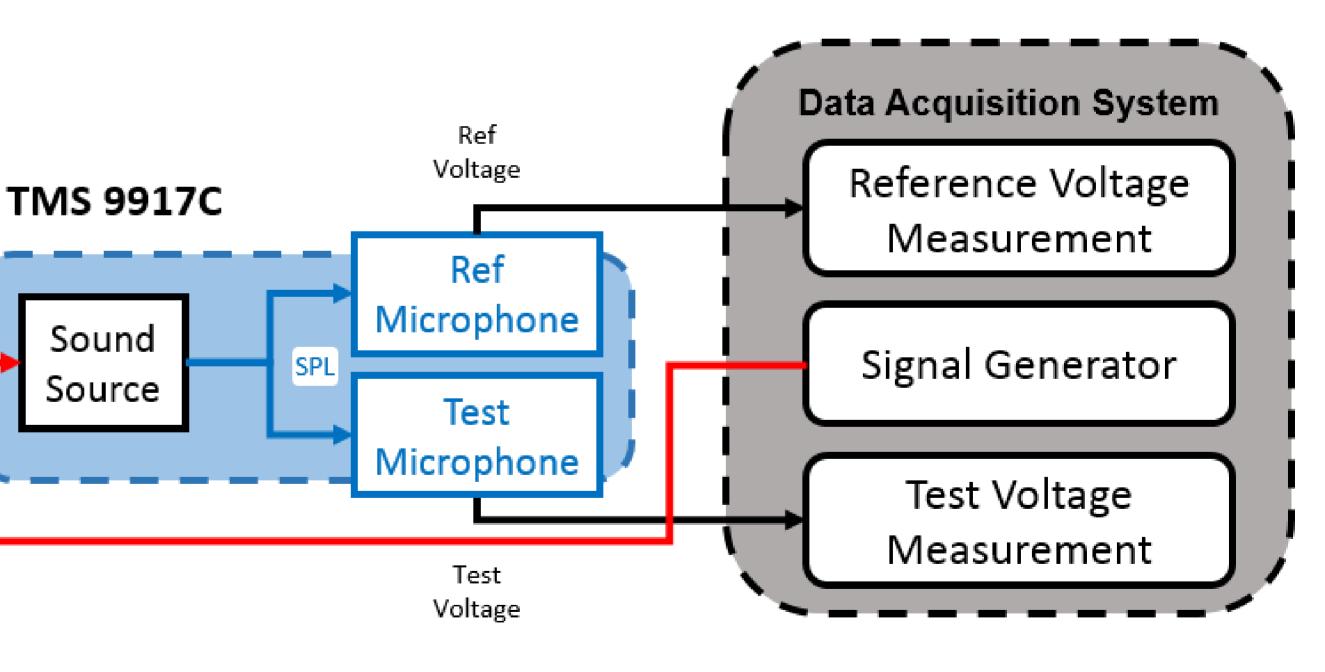
Minimal Additional Instrumentation Required



Max 2Vpk









 $M_{Test} = M_{Ref} \times \frac{R_V}{R_P} \times C_{F/P}$ 





- $M_{Test}$  sensitivity of the test microphone, in  ${}^{mV}/{}_{Pa}$
- $M_{Ref}$  sensitivity of the reference microphone, in  ${}^{mV}/{}_{Pa}$
- *R<sub>V</sub>* ratio of the voltage output of the test microphone to the voltage output of the reference microphone
- *R<sub>P</sub>* ratio of the sound pressure on the test microphone to the sound pressure on the reference microphone
- $C_{F/P}$  field correction value referenced to the pressure response for the test microphone.

## **PRESSURE SENSOR CALIBRATION**

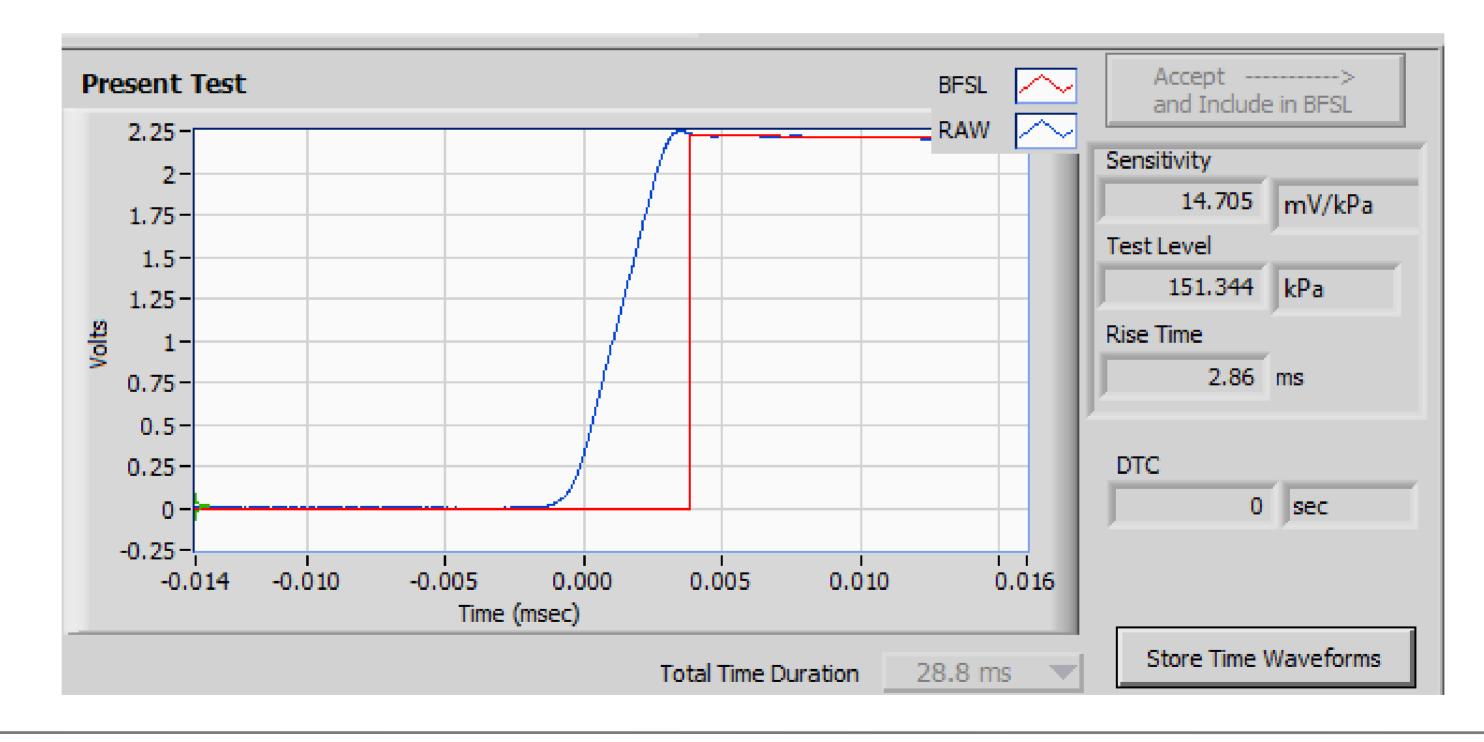
- 2 Methods
  - Step Method
  - Impulse Method





## **CALIBRATION – STEP METHOD**

- Quick rise in pressure is applied
- Dynamic calibration using a static reference

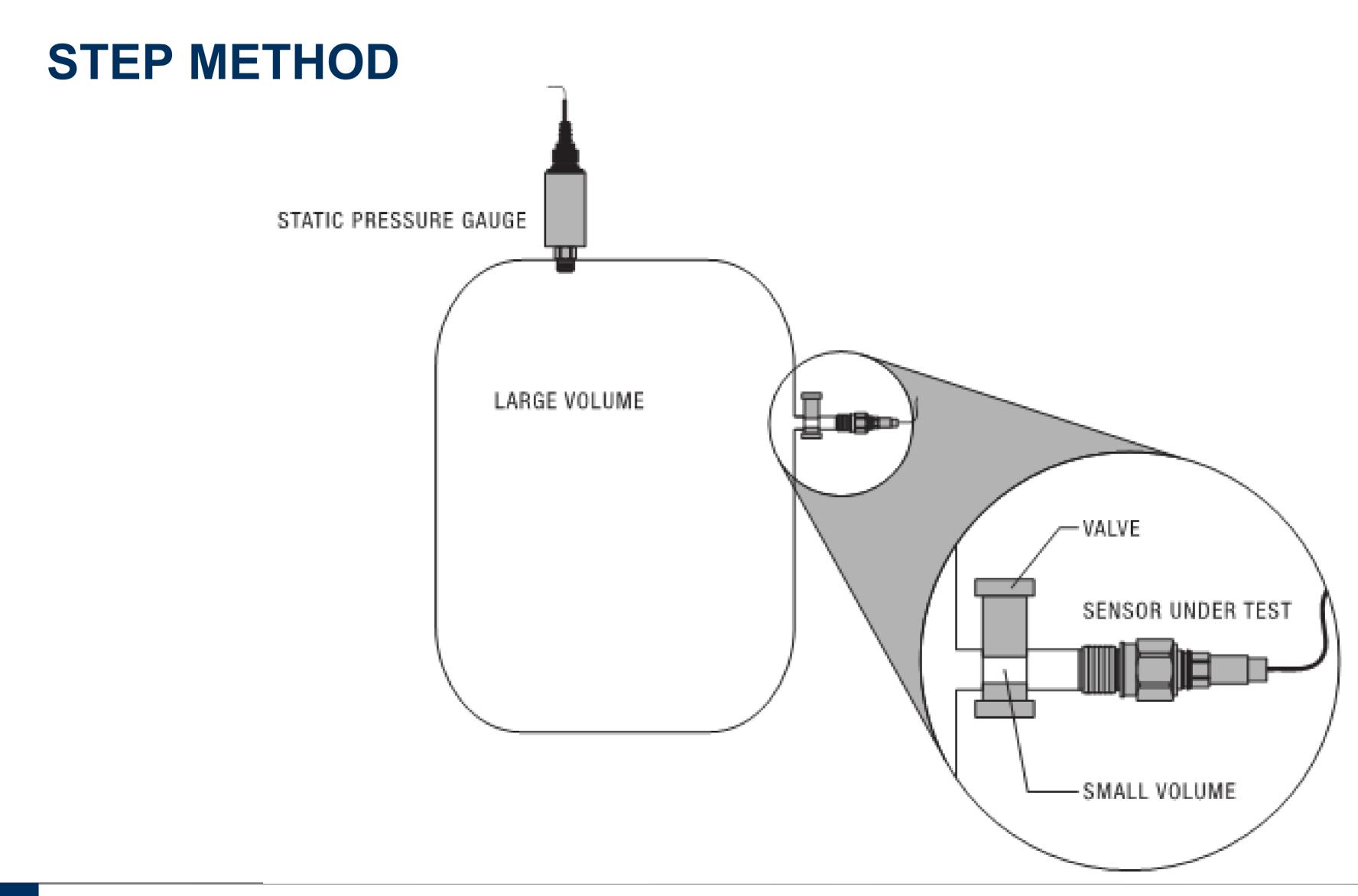








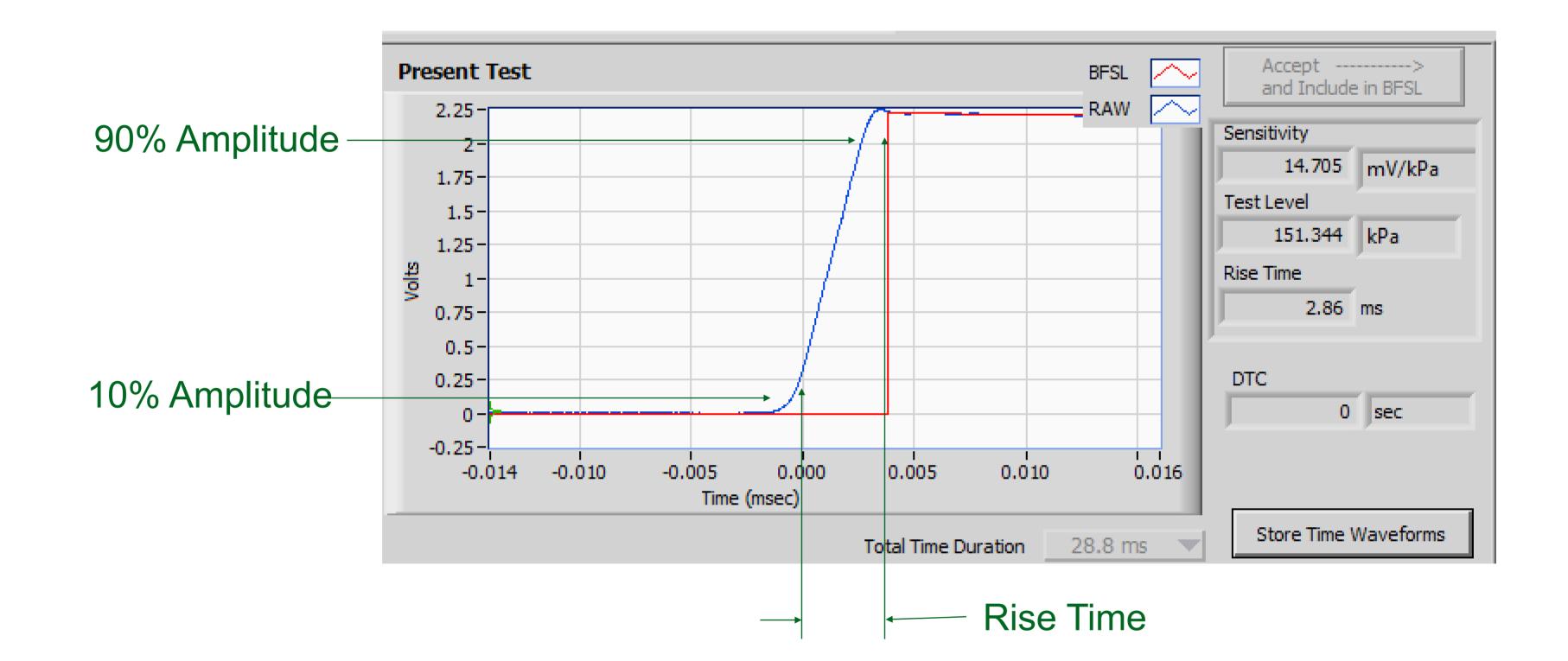
#### Voltage Rise<sub>sur</sub> Sensitivity<sub>sur</sub> = <u>\_\_\_\_</u> Reference Pressure







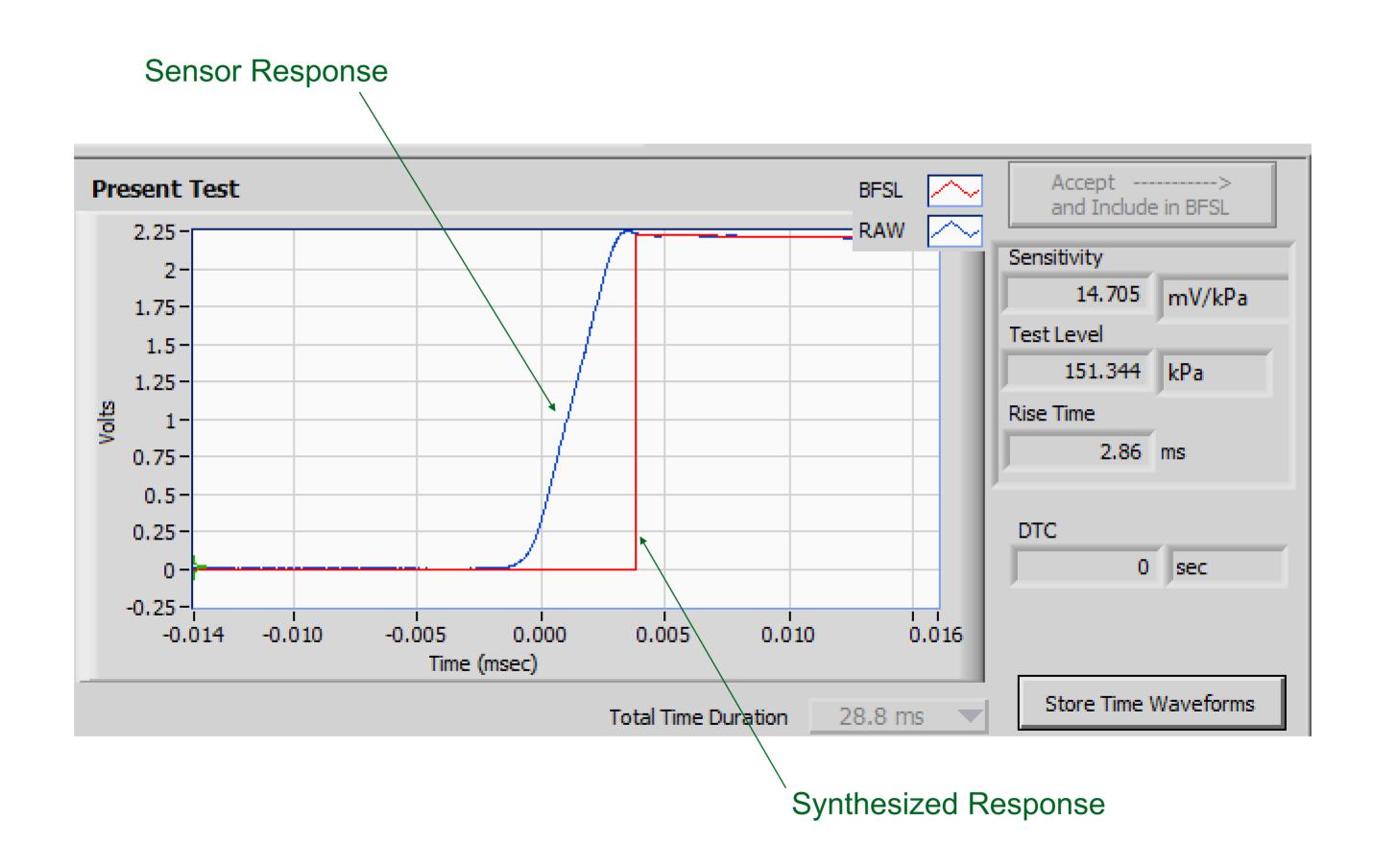
## **RISE TIME MEASUREMENT**







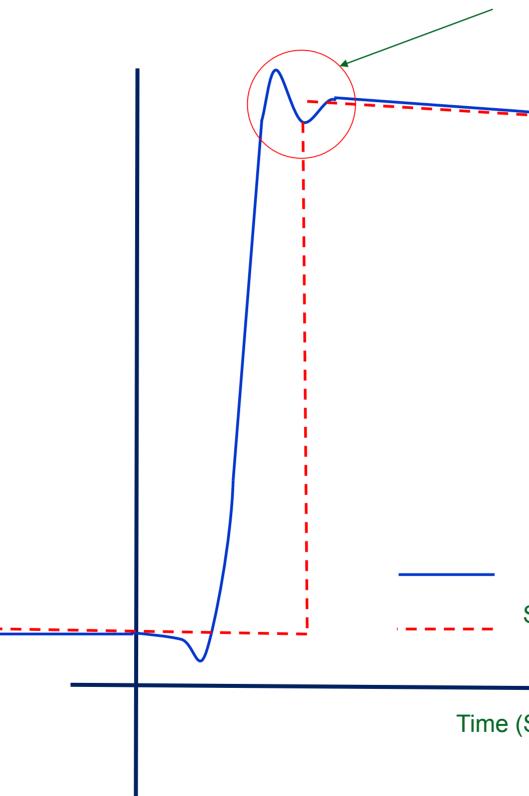
## **'STEP' DATA ACQUISITION SOFTWARE (K9903C, K9907C)**







## SYNTHESIZED RESPONSE ALGORITHM







Ignores Acoustic Resonances For Fixed Time Period

Compensates For AC Coupling With Exponential Curve Fit

Sensor Response

Synthesized Response

Time (Seconds)

## **STEP METHOD**

- K9903C
- Max Pressure = 150 psi
- 'Step' Input
- Pneumatic Media
- 3 to 5 ms rise time







## **STEP METHOD**

- K9907C
- Max Pressure = 1000 psi
- 'Step' Input
- Helium Gas
- 30 to 50 µsec rise time
- Fast acting poppet valve







## **STEP METHOD**

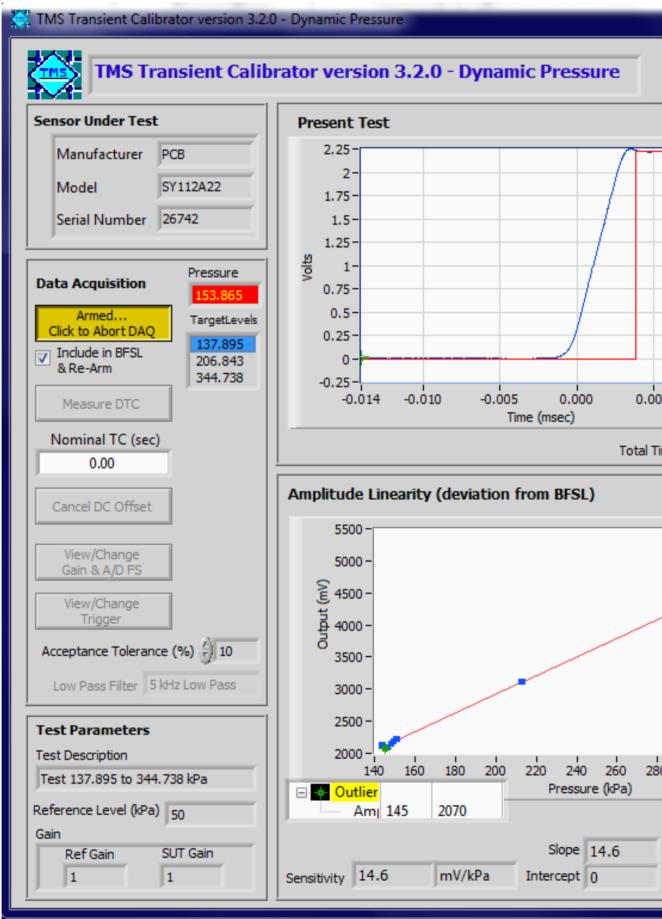
- K9905D
- Max Pressure = 80 kpsi
- 'Step' Input
- Silicon Oil Media







## **'STEP' DATA ACQUISITION SOFTWARE (K9903C, K9907C, K9905D)**







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	T Max SUTMax/Ref	Мах					
· · · · ·	.22544 0 Accept>						_
BFSL	and Include in BFSL	Previous Tests at This Level					
RAW	Sensitivity	Outpu	t (mV)	Pressure (kPa)	System Rise Tim		
	14.705 mV/kPa	2094.9		146.43		2,7200	
	Test Level	2153.0		148.45	2.8600		
	151.344 kPa	2192.3		149.70	2.8400	2.8400	
	Rise Time	2214.7		150.64	2.7400	2.7400	
	2.86 ms	2225.	4	151.34	2.8600	7	
	2.00 ms		)elete Sele	ected Data	7	Entries	
	DTC 0 sec	2154.	178	147.863	2.74	Average	s
05 0.010 0.016	, , , , , , , , , , , , , , , , , , , ,	59.78	39	2.9771	0.1536	Std Dev	
Time Duration 28.8 ms	Store Time Waveforms	Average					
		Target Level	Avg Output		System Rise Time	% Linearity Ref Level	*
Amp Linearity	Combined Data	137.9	2154.2		2.7400	0.53	
BFSL	Pressure (kPa) 分 137.895	206.8 344.7	3124.0 4948.6		2.6633 2.3767	2.32 1.20	
<u></u>	Output (mV) Pressure (kPa)						
	2094.9 146.43		<u> </u>				
	2153.0 148.45			_			
	2192.3 149.70						
	2214.7 150.64						
	2225.4 151.34						
80 300 320 340 360	Delete Selected Data						
	Avg Output (mV) Pressure (kPa)						
Delete	2154.2 147.86						T
Nominal Linearity 1	%						
Max deviation from BFSL 2.3	Store All Data R				eturn		
							-

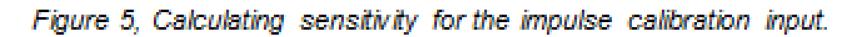
## **CALIBRATION – IMPULSE METHOD**

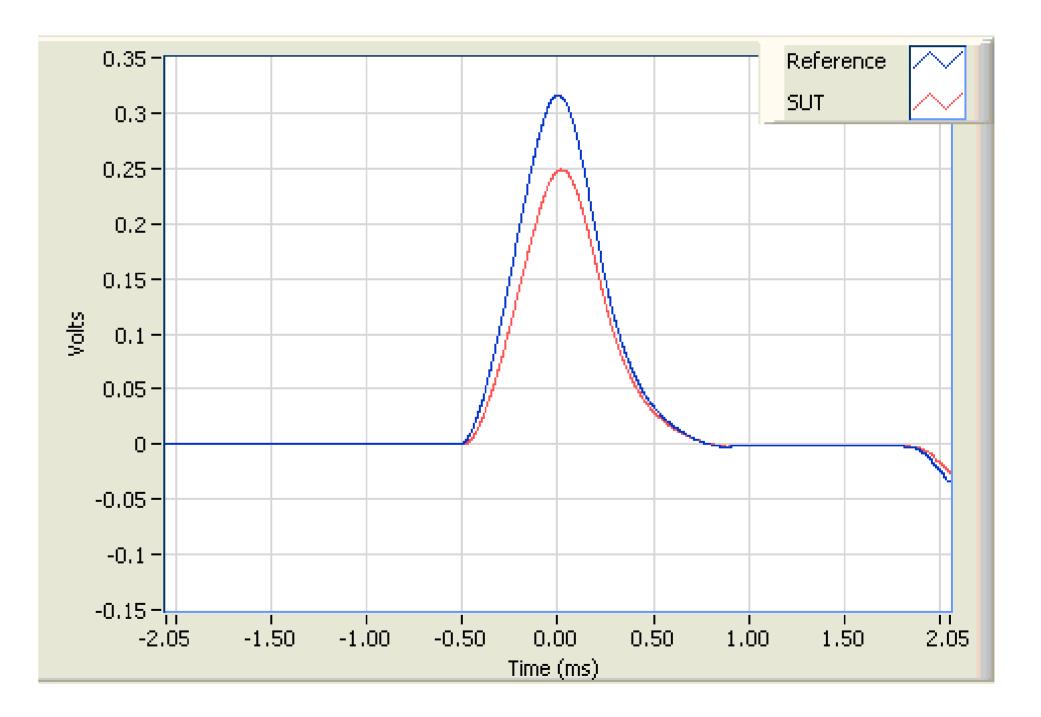
- Quick rise and fall in pressure
- Dynamic calibration using a piezoelectric reference
- Comparison calculation
- Traceability through static methods





# $Sensitivity_{SUT} = \frac{Voltage_{SUT}}{Voltage_{Ref}} \times Sensitivity_{Ref}$



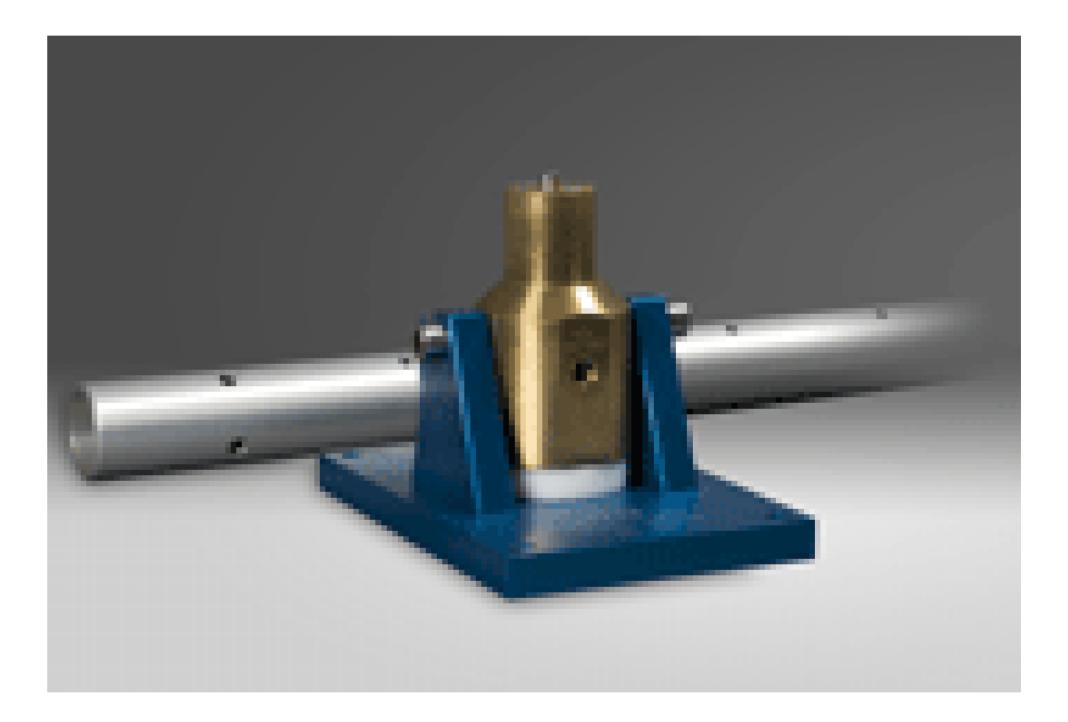


## **IMPULSE METHOD**

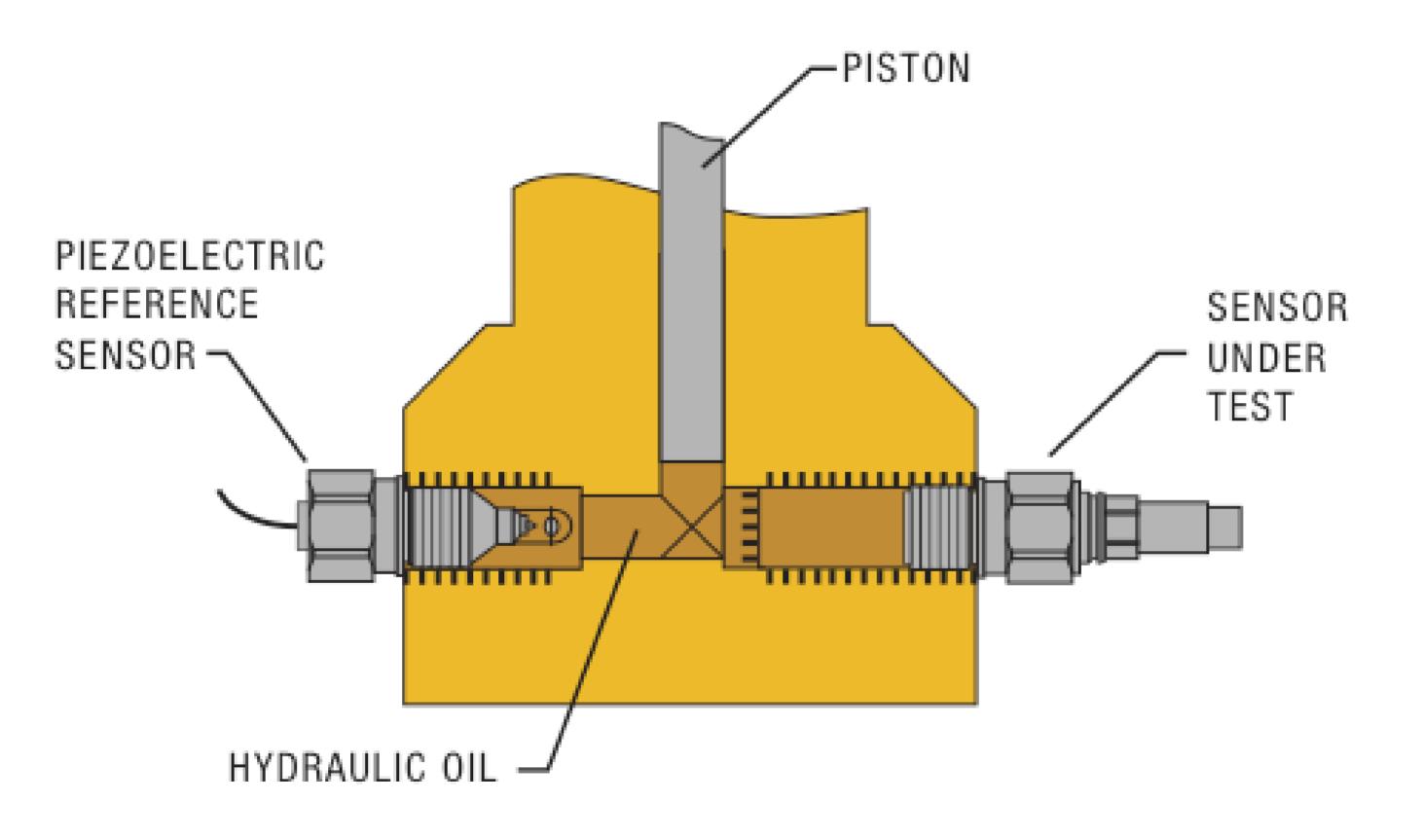
- Max Pressure = 15 ksi
- Impulse (Hammer) Input
- Silicon Oil Media
- Dropped Masses







# IMPULSE METHOD







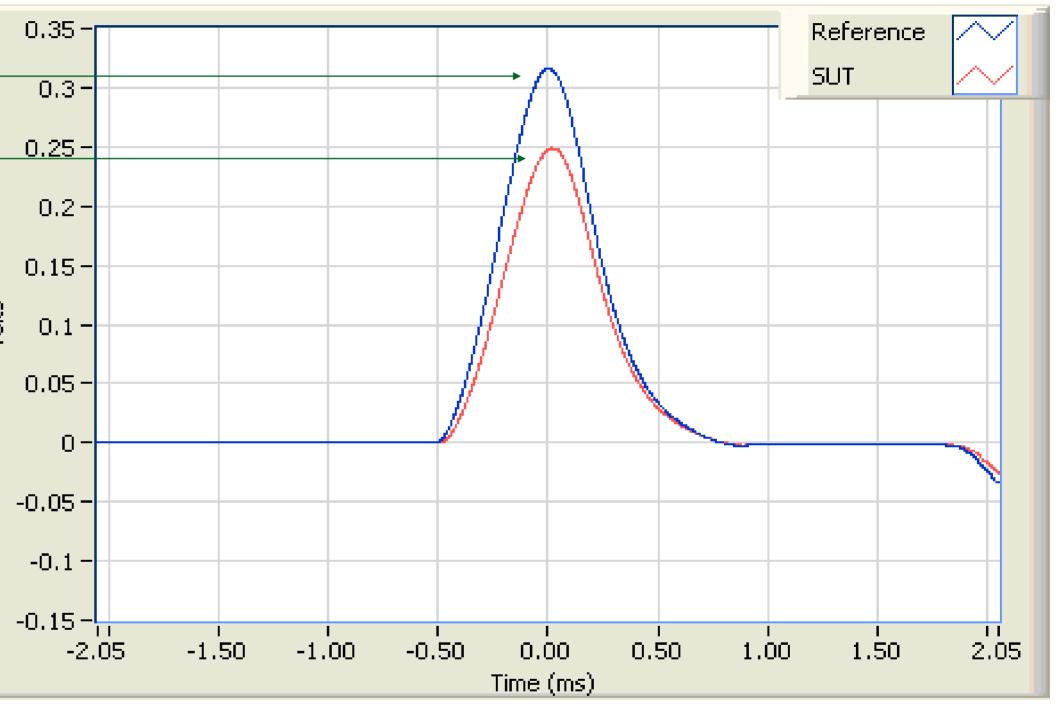
## **IMPULSE DATA ACQUISITION SOFTWARE**

Peak Output – Reference Sensor — Peak Output – Sensor Under Test — Sensor Under Test

 $Sens_{SUT} = Sens_{Ref} \frac{Voltage_{SUT}}{Voltage_{Reference}}$ 







# **IMPULSE DATA ACQUISITION SOFTWARE**

